



GEMaC

Groupe d'Étude
de la Matière Condensée

EPITAXY AND MATERIAL ELABORATION

- » ALD for oxides
- » Diamond plasma CVD
- » PLD for oxides
- » MOCVD of II-VI semiconductors
- » Metal and oxide deposition
- » Material shaping
- » Optical lithography
- » Pre- and post-growth processing